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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10033950	FILING DATE 12/28/2001	CLASS 750 436	SUBCLASS 557.27	GAU 2812	EXAMINER Luy
**APPLICANTS: Ziegler Jurgin; Waller Reinhold; Pfitzner Lothar; Schneider Claus; Ryssel Heiner; Tegeder Volker;					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A CON OF PCT/DE00/02116 06/28/2000					
** FOREIGN APPLICATIONS VERIFIED: GERMANY 199 29 615.4 06/28/1999					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 1999P8173	
Verified and Acknowledged Examiners's initials					
TITLE : Apparatus for monitoring intentional or unavoidable layer depositions and method					
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
		Sheets Drwg.	Figs. Drwg.
		Print Fig.	
Primary Examiner		Applicati n Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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